

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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6-30-98  
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Serial No.: TBD Art Unit: TBD  
Prior Filed: 5/30/97 Examiner: TBD  
Prior Serial No.: 60/048,212 Docket: TI-25588  
Inventor: Richard T. Goldberg  
For: Method For Thermal Nitridation and/or Oxidation of Semiconductor  
Surface and Related Processing Equipment

PRELIMINARY AMENDMENT

Assistant Commissioner For Patents  
Washington, D.C. 20231

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Date of Deposit:

5/20/98

Dear Sir:

Prior to examination, please amend this application as follows and charge any necessary fees to deposit account 20-0668 of Texas Instruments Incorporated:

IN THE SPECIFICATION

Please amend page 1, after the "Title of the Invention" by inserting the following:

a' --This is a Non Provisional application filed under 35 USC 119(e) and claims priority of prior provisional, Serial No. 60/048,212 of inventor Richard T. Goldberg, filed 5/30/97.--